

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Lu et al.	Art Unit:	2826
Serial No.:	10/722,013	Examiner:	Erdem, F.
Filing Date:	11/25/2003	Docket No.:	TI-35669
Customer No.:	23494	Conf. No.:	6979
Title:	A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER AND A METHOD OF MANUFACTURE THEREFOR		

AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated May 7, 2007. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification**.

Amendments to the Claims are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings**.

The **Remarks** begin on page 7.